

**AMENDMENTS TO THE SPECIFICATION**

Following the title, please insert the following paragraphs:

**Cross-Reference to Prior Application**

This is a U.S. National Phase application under 35 U.S.C. §371 of International Patent Application No. PCT/JP2004/005285 filed April 14, 2004, and claims the benefit of Japanese Patent Application Nos. 2003-109835 filed April 15, 2003; 2003-109719 filed April 15, 2003; 2003-321893 filed September 12, 2003; 2003-323173 filed September 16, 2003; 2004-058778 filed March 3, 2004 and 2004-108732 filed April 1, 2004, all of which are incorporated by reference herein. The International Application was published in Japanese on October 28, 2004 as WO 2004/091810 A1 under PCT Article 21(2).

Please replace the paragraph starting from page 63, line 20 with the following amended paragraph:

--FIG. 2 shows FIGS. 2A-2D show SPM charts during a process for forming SAM-27, wherein the charts represent the organic thin film obtained after immersion times of (a) less than 1 second, (b) 15 seconds, (c) 30 seconds, and (d) 1 minute.--

Please replace the paragraph starting from page 64, line 1 with the following amended paragraph:

--FIG. 3 shows FIGS. 3A-3D show SPM charts during a process for forming SAM-31, wherein the charts represent the organic thin film obtained after immersion times of (a) less than 1 second, (b) 15 seconds, (c) 1 minute, and (d) 5 minutes.--